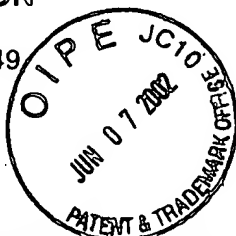


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	APPLICANT: Bergh, et al.	
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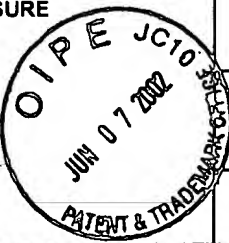
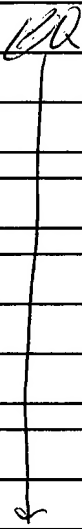

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